



00862.022445.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takehiko MAYAMA

Application No.: 09/990,350

Filed: November 23, 2001

For: ACTIVE VIBRATION SUPPRESSION
APPARATUS, CONTROL METHOD THEREFOR,
AND EXPOSURE APPARATUS HAVING ACTIVE
VIBRATION SUPPRESSION APPARATUS

: Examiner: Unassigned

) : Group Art Unit: 2812

: :

: :

) February 27, 2002

Commissioner for Patents
Washington, D.C. 20231

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SUBMISSION OF PRIORITY DOCUMENTS

Sir:

In support of Applicant's claim for priority under 35 U.S.C. § 119, enclosed are certified copies of the following foreign applications:

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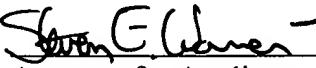
JAPAN 2000-359969, filed November 27, 2000, and

JAPAN 2001-002436, filed January 10, 2001.

GROUP 3600

Applicant's undersigned attorney may be reached in our Washington, D.C., office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicant
Steven E. Warner
Registration No. 33,326

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